Quantum-Nano Fabrication & Characterization Facility (QNFCF)

Core Scientific Research Platform

Facility Usage Stats and Highlights

July 27, 2021





Facility Overview

Distributed across 13 sites - Centrally managed under Office of Research

\$63M in Capital Investments

QNC Building

\$25M ISO 4 rated Cleanroom

VC-G rated Metrology labs

\$26M Lab equipment

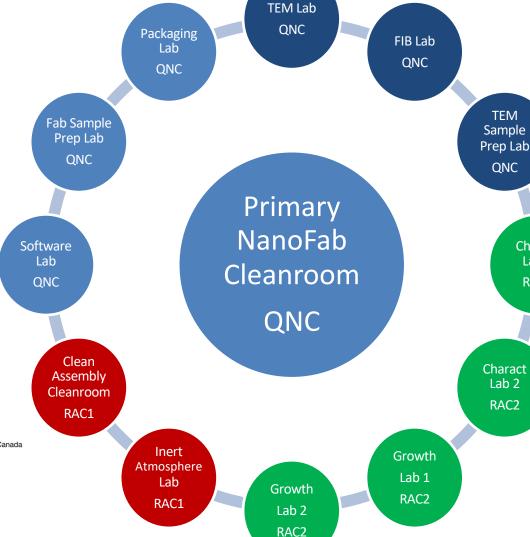
RAC1 Building

\$1M ISO 6 rated Cleanroom

\$1M Lab equipment

RAC2 Building

\$10M Lab equipment



Charact

Lab 1

RAC2

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Innovation, Science and Economic Development Canada



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Transformative
Quantum
Technologies

Broad Range of Capabilities

Deposition

- 1. ALD / PECVD Cluster Deposition System
- 2. LPCVD Low Temperature Oxidation (LTO) Furnace
- 3. LPCVD Poly Silicon and Silicon Carbide Furnace
- 4. LPCVD Silicon Nitride Furnace
- 5. Rapid Thermal Processor #1 (RTP)
- 6. Rapid Thermal Processor #2 (RTP)
- 7. PVD E-Beam & Resistive Heating Thermal Evaporator
- 8. PVD E-Beam Long Throw Evaporator
- 9. PVD Nb Superconducting Films Sputter System
- 10. PVD Twin Chamber Sputter System
- 11. PVD Al Superconducting Films Evaporator System
- 12. PVD Thermal Evaporator for P-Type Contacts
- 13. Thermal Oxidation Furnace

Lithography

- 1. E-Beam Lithography System (30kV)
- 2. E-Beam Lithography System (100kV)
- 3. Beamer/Tracer Software Suite
- 4. Front/Back Mask Aligner
- 5. Wafer Bonder
- 6. UV Direct Write Lithography System
- 7. Oven: Convection
- 8. Oven: HMDS & Image Reversal
- 9. Spin Coater: Dual General Purpose Hood
- 10. Spin Coater: E-Beam Resists
- 11. Spin Coater: UV Resists

Dry Etch

- 1. Ion Mill
- 2. Photoresist Strip
- 3. RIE: Deep Silicon Etch (DRIE)
- 4. RIE: Metal & III-V Materials

Wet Benches

- 1. Bulk Silicon Etch
- 2. Critical Point Dryer
- 3. Diffusion Pre-Clean (RCA Chemistries)
- 4. E-Beam Resist Develop
- 5. HF Acids Only
- 6. Non-HF Acids & Bases
- 7. Piranha Organics Clean & Resist Strip
- 8. Solvent Processing Station #1
- 9. Solvent Processing Station #2
- 10. UV Resist Develop

Characterization

- 1. Bruker Atomic Force Microscope
- 2. Scanning Electron Microscope
- 3. Manual Cleaving Tool
- 4. 4-Point Probe
- 5. Electrical Prober Station: Generous donation from EVERBEING
- 6. Electrical Probe Station
- 7. Ellipsometer
- 8. Microscope #1
- 9. Microscope #2
- 10. Reflectometer: Thin Film Mapping
- 11. Reflectometer: Thin Film Spot Measurement
- 12. Surface Profiler #1
- 13. Surface Profiler #2
- 14. Wafer Stress Measurement
- 15. SEM Sample Coater

Packaging Lab

- 1. Convection Cure Oven
- 2. Dicing Saw
- 3. Die Bonder
- 4. H2 Plasma Cleaner
- 5. Measurement Microscope
- 6. Wirebonder: Manual Wedge/Ball
- 7. Wirebonder: Semi-automatic Wedge

3

- 8. Wire Pull Tester
- 9. Epoxy dispenser

QNC Metrology Labs

- 1. SEM/FIB System
- 2. S/TEM System
- 3. Dry Sample Prep Lab

RAC1 Labs

- 1. Assembly Station #1
- 2. Assembly Station #2
- 3. Environmental Chamber
- 4. Laser Welder
- 5. Sample Polisher
- 6. Sample Cutter
- 7. Sample Lapper
- 8. Wire Saw
- 9. Microscope #1
- 10. Microscope #2
- 11. Microscope #3
- 12. 02/Ar Plasma Cleaner
- 13. Wet Bench: Non-HF Acids & Bases
- 14. Wet Bench: HF Acids
- 15. Wet Bench: Solvent Processing
- 16. Wire Bonder
- 17. 3D Optical Surface Profiler

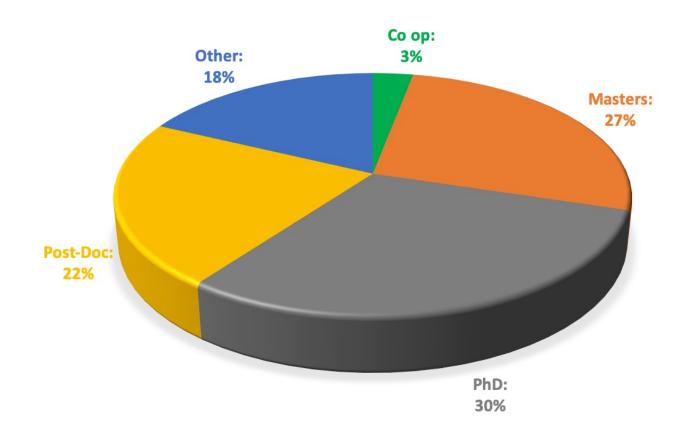
RAC2 Labs

- 1. Fiber Splicer
- 2. Microscope #2
- 3. Veeco Atomic Force Microscope
- 4. LPCVD for Carbon Nanotube Growth
- 5. Pulsed Laser Deposition System



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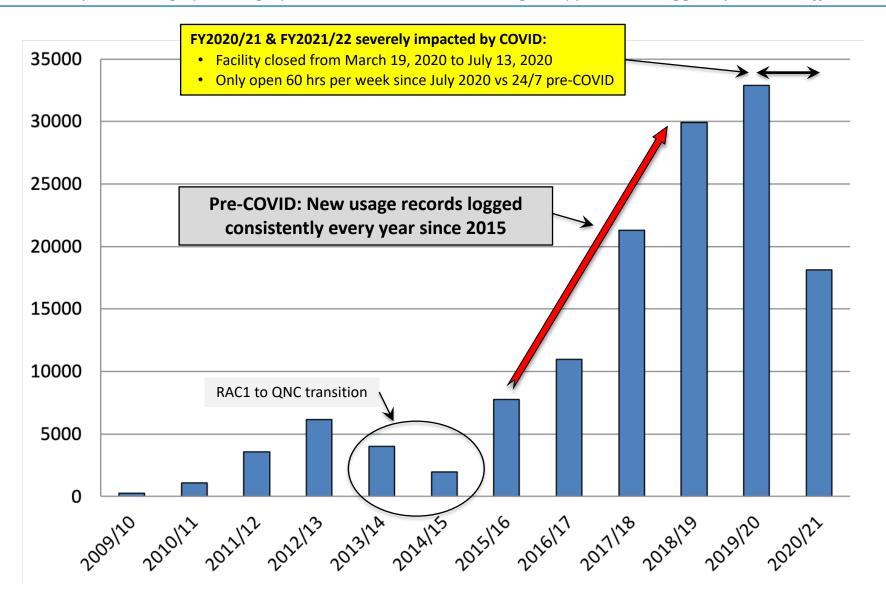
Well used by broad range of Lab Members (Users)





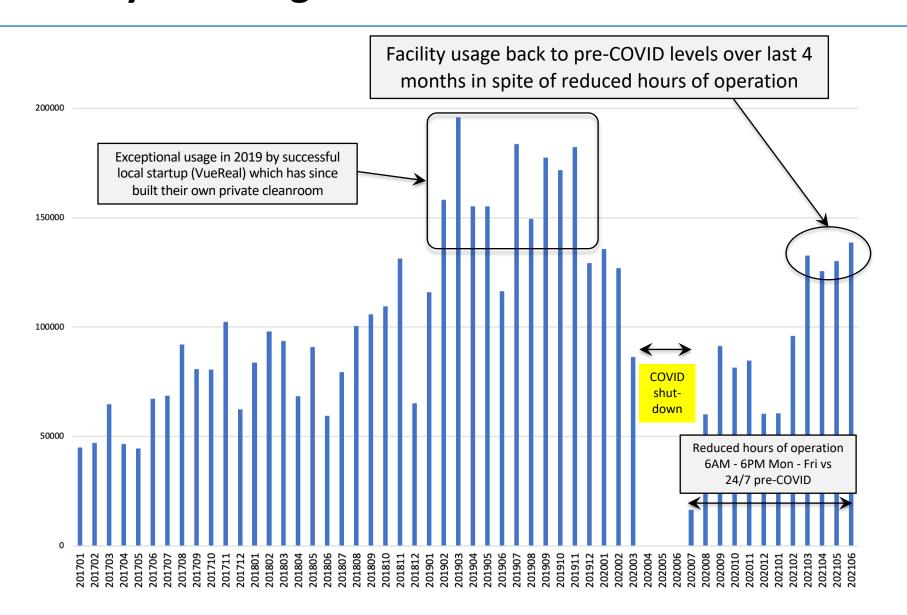
Hours of equipment use invoiced per fiscal year*

* Fiscal years ending April 30 - graph does not include user training & support hours logged by QNFCF staff





Monthly invoicing trends: Jan 2017 to June 2021



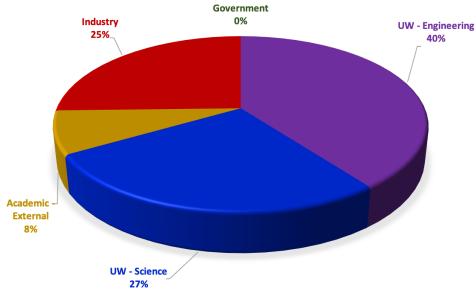


FY2020/21: 164 Users under 63 distinct research groups

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Principal Investigator	Hours of Equip	Category: Academic,	Institution / Company Name	Faculty	Department	
	Use Logged	Industry, Govt, Other				
Abdel-Rahman, Eihab		Academic	UW	Engineering	Sys Design Eng	
Alfano, Marco		Academic	UW	Engineering	MME	
Bajcsy, Michal		Academic	UW	Engineering	ECE	
Cui, Bo		Academic	UW	Engineering	ECE	
Daun, Kyle		Academic	UW	Engineering	MME	
Goldthorpe, Irene		Academic	UW	Engineering	ECE	
Karim, Karim		Academic	UW	Engineering	ECE	
KIM, Na Young	67	Academic	UW	Engineering	ECE	
Mansour, Raafat	660	Academic	UW	Engineering	ECE	
Mayer, Michael	11	Academic	UW	Engineering	MME	
Miao, Guo-Xing	125	Academic	UW	Engineering	ECE	
Mitra, Sushanta	5	Academic	UW	Engineering	MME	
Musselman, Kevin	142	Academic	UW	Engineering	MME	
Nieva, Patricia	2	Academic	UW	Engineering	MME	
Reimer, Michael	431	Academic	UW	Engineering	ECE	
Safavi-Naeini, Safieddin	41	Academic	UW	Engineering	ECE	
Sivoththaman, Siva	19	Academic	UW	Engineering	ECE	
Wasilewski, Zbigniew	81	Academic	UW	Engineering	ECE	
Wei, Lan	5	Academic	UW	Engineering	ECE	
Wilson, Christopher	1792	Academic	UW	Engineering	ECE	
Wong, William	160	Academic	UW	Engineering	ECE	
Yavuz, Mustafa	112	Academic	UW	Engineering	MME	
Yeow, John	251	Academic	UW	Engineering	Sys Design Eng	
Yim, Evelyn	190	Academic	UW	Engineering	Chem Eng	
Yu, Alfred	45	Academic	UW	Engineering	ECE	
Baugh, Jonathan	2526	Academic	UW	Science	Chemistry	
Budakian, Raffi	96	Academic	UW	Science	Physics	
Choi, Kyung Soo	1	Academic	UW	Science	Physics	
Cory, David	1912	Academic	UW	Science	Chemistry	
Forrest, James	29	Academic	UW	Science	Physics	
Islam, Rajibul	29	Academic	UW	Science	Physics	
Jennewein, Thomas		Academic	UW	Science	Physics	
Kycia, Jan	9	Academic	UW	Science	Physics	
Lupascu, Adrian	767	Academic	UW	Science	Physics	
Mariantoni, Matteo	197	Academic	UW	Science	Physics	
Resch, Kevin		Academic	UW	Science	Physics	
Schipper, Derek	12	Academic	UW	Science	Chemistry	
Sciaini, German		Academic	UW	Science	Chemistry	
Senko, Crystal		Academic	UW	Science	Physics	
Slavcev. Roderick		Academic	UW	Science	Pharmacy	
Tsen, Adam Wei		Academic	UW	Science	Chemistry	
Maheshwari. Vivek		Academic	UW	Science	Other	

Principal Investigator	Hours of Equip	Category: Academic,	Institution / Company Name	Faculty	Department
	Use Logged	Industry, Govt, Other			
Helmy, Amr	1134	Academic - External	University of Toronto	N/A	N/A
Hryciw, Aaron	8	Academic - External	University of Alberta	N/A	N/A
Kherani, Nazir	49	Academic - External	University of Toronto	N/A	N/A
Miller, R.J Dwayne	74	Academic - External	University of Toronto	N/A	N/A
Pahlevani, Majid	48	Academic - External	University of Queens	N/A	N/A
Ban, Dayan (VueReal)	852	Industry	UW	Engineering	ECE
Abdel Aziz, Ahmed	50	Industry	Simwi Tech Corp	N/A	N/A
Boorn, Andrew	7	Industry	High Q Technologies, LP	N/A	N/A
Fathi, Ehsanollah	51	Industry	VueReal Inc	N/A	N/A
Galaom, Ahmed	392	Industry	Sheba Microsystems	N/A	N/A
Hamilton, Parisa (UW Velocity)	13	Industry	LSK Technologies	N/A	N/A
Khosraviani, Kourosh	5	Industry	Adhawk Microsystems	N/A	N/A
MacLean, Steve	41	Industry	Infinite Potential Laboratories	N/A	N/A
Martinho, John	1	Industry	RANOVUS	N/A	N/A
Morris, David	66	Industry	ICSPI Corp.	N/A	N/A
Najafi-Yazdi, Alireza	1124	Industry	Anyon Systems Inc	N/A	N/A
Peinke, Emanuel	12	Industry	TandemLaunch, Inc.	N/A	N/A
Rezazadeh, Vallen	6	Industry	TransEON Inc.	N/A	N/A
Robson, Mitchell	40	Industry	Ambature Inc.	N/A	N/A
Shaffer, James	365	Industry	Quantum Valley Ideas Lab	N/A	N/A
Xiang, Jingen	164	Industry	SpinQ Technologies	N/A	N/A

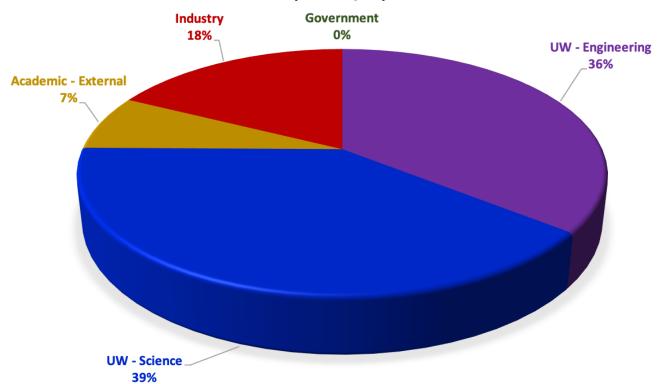
QNFCF PI BREAKDOWN AS A FUNCTION OF AFFILIATION (FY2020/21)





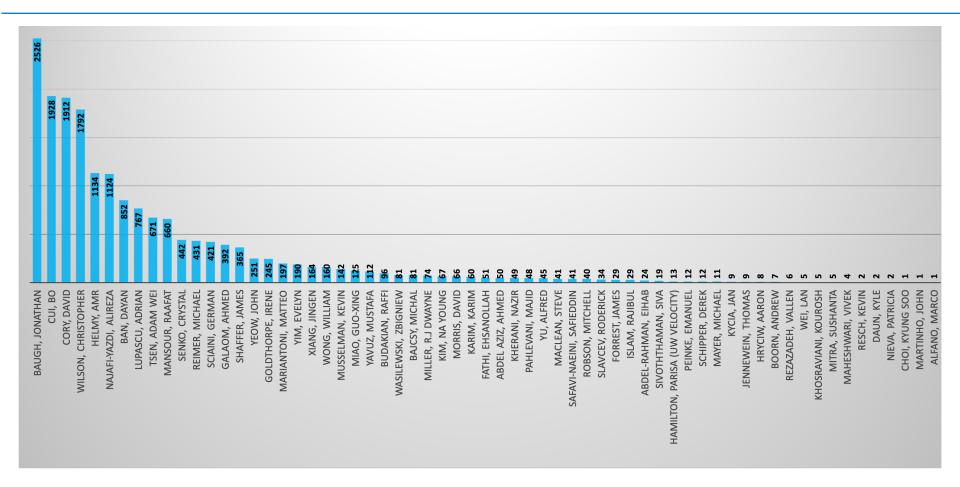
FY2020/21: % of total hours of use per category of affiliation





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FY2020/21: Hours of use logged per PI



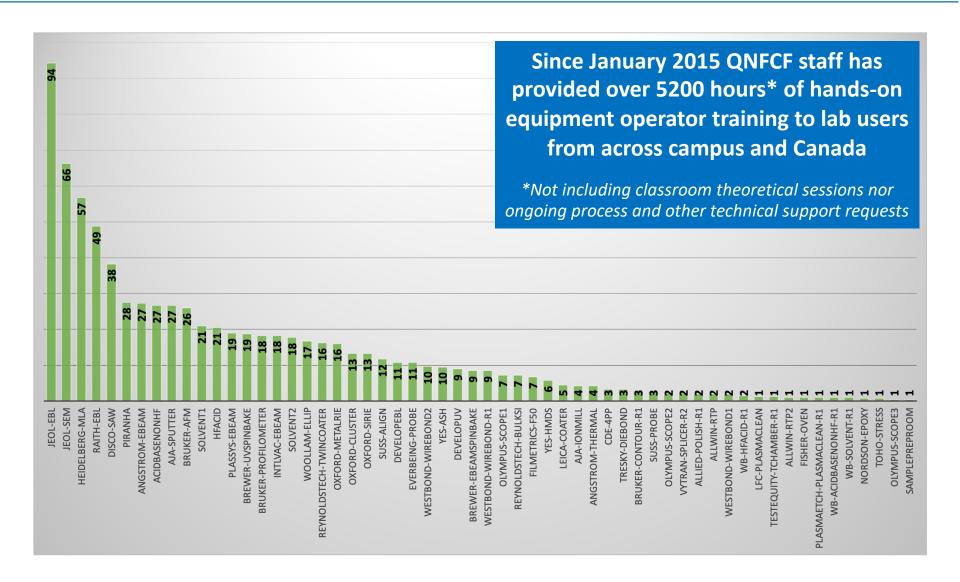
Top 3 QNFCF users in FY 2020/21 (most active research groups):

- Jonathan Baugh
- Bo Cui
- **David Cory**

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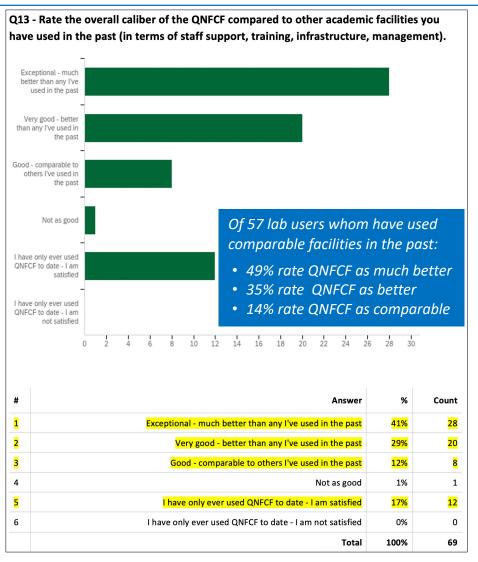


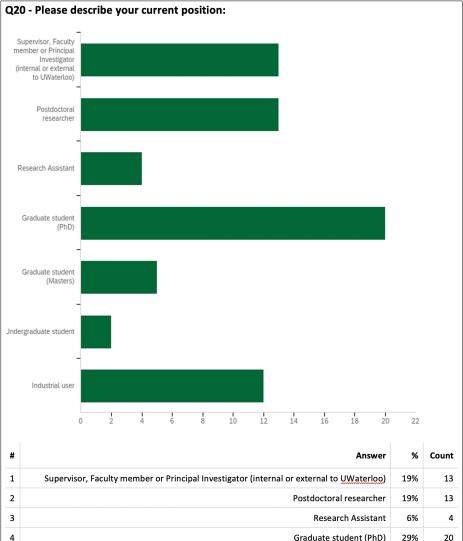
FY2020/21: Logged 800 Hours of hands-on training



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Highlight from July 2021 Lab Member survey





Graduate student (Masters)

Undergraduate student

Industrial user

Total

7%

3%

17%

100%

5

2

12

69

5

6

Annual O&M expenses and User fees trends*

* Fiscal years ending April 30

EXPENSES	2012	2013	2014	2015	2016	2017	2018	2019	2020	2021	Average Last 3 Years
SALARIES & BENEFITS Sub-Total:	\$222,645	\$274,113	\$290,309	\$365,712	\$460,623	\$613,184	\$819,592	\$1,535,502	\$1,701,655	\$1,778,492	\$1,671,883
SUPPLIES, MAINTENANCE & REPAIRS Sub-Total:	\$101,393	\$122,271	\$506,975	\$405,379	\$589,031	\$802,204	\$1,163,558	\$1,380,003	\$1,400,137	\$1,071,837	\$1,283,992
TOTAL:	\$324,038	\$396,384	\$797,285	\$771,091	\$1,049,653	\$1,415,388	\$1,983,150	\$2,915,505	\$3,101,791	\$2,850,329	\$2,955,875
USER FEES COLLECTED	\$86,583	\$157,915	\$111,333	\$80,860	\$348,371	\$539,638	\$994,730	\$1,376,704	\$1,763,769	\$877,024	\$1,339,166
% EXPENSES COVERED BY USER FEES	27%	40%	14%	10%	33%	38%	50%	47%	57%	31%	45%

In addition to several million dollars contributed towards multiple lab renovations and equipment acquisitions & upgrades, IQC and CFREF-TQT have also made substantial contributions towards the QNFCF's routine operating expenses over the past 10 years:

• IQC: \$3,551,105

• CFREF-TQT: \$1,915,520



Summary of key QNFCF success factors

- 1. Outstanding multi-year financial support from IQC and CFREF-TQT
- 2. Rare ensemble of lab equipment backed by solid expertise
- 3. QNFCF Team with extensive technical & operations experience
- 4. Strong focus on customer service
- 5. Revision-tracked SOPs / well-characterized recipes / process support
- 6. Extensive mandatory training
- 7. Stable, professionally-maintained lab equipment & infrastructure
- 8. Clearly defined, communicated & enforced policies (fair access to all)
- 9. UWaterloo's "creator owned" IP policy

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